

In re the Application of:

Group Art Unit: 2825

Examiner: Whitmore, Stacy

Confirmation No.: 5787

For: METHOD AND SYSTEM FOR FACILITATING ELECTRONIC CIRCUIT AND CHIP DESIGN USING REMOTELY LOCATED RESOURCES

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed June 07, 2007, Applicants respectfully request to amend the application as follows:

Amendments to the Claims begin on page 2.

Remarks begin on page 11.